



I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: June 27, 2007

Signature: Richard H. Anderson

(Richard H. Anderson)

Docket No.: 28569/38510A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Mingming Fang et al.

Application No.: 10/713,709

Confirmation No.: 2098

Filed: November 14, 2003

Art Unit: 1765

For: Chemical-Mechanical Polishing (CMP) Slurry
and Method of Planarizing Computer Memory
Disk Surfaces

Examiner: K. C. Chen

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the election/restriction requirement dated June 18, 2007, applicants hereby elect, with traverse, the claims of Group II (claims 14-20).

It is submitted that since the elected method claims 14-20 include all of the features of the composition claims 1-13, there would be no serious burden on the Examiner to include claims 1-13 in the examination of this application.

Examination of all claims 1-20 is respectfully requested.

Dated: June 27, 2007

Respectfully submitted,

By Richard H. Anderson

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